

SHEET 1 OF 1

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INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		APPLICANT MIZUHARA et al.	
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## OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

A1.	Wolf, et al., "Silicon Processing for the VLSI Era: Volume 1 - Process Technology", Lattice Press, 1986, page 441.
A2.	Wolf, "Silicon Processing for the VLSI Era: Volume 2 - Process Integration", Lattice Press, 1990, pages 232-233.

EXAMINER	DATE CONSIDERED
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	